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Applicant

Hong-Miao Chen et al.

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INFORMATION DISCLOSURE CITATION  
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(Use several sheets if necessary)

## U. S. PATENT DOCUMENTS

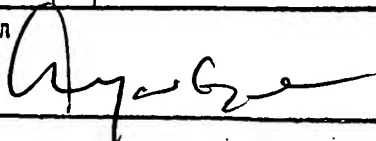
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	PLUG DATE IF APPROPRIATE
1A	6055106	4/25/00	Grier et al.	359	566	2/3/98
	5953166	9/14/99	Shikama	359	837	11/21/97
	5689109	11/18/97	Schutze	250	251	1/13/94
	5620857	4/15/97	Weetall et al.	435	7.1	6/7/95
	5245466	9/14/93	Burns et al.	359	296	10/8/91
	5079169	1/7/92	Chu et al.	436	172	5/22/90
	4893886	1/16/90	Ashkin et al.	350	1.1	9/17/87
	5512745	4/30/96	Finer et al.	250	251	3/9/94
	3808550	4/30/74	Ashkin	331	94.5	1/24/72
1A	6139831	10/31/00	Shivashankar et al.	424	8205	5/28/98

## FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
					YES	NO

## OTHER DOCUMENTS (Including Author, Title, Date, Portion or Pages, Etc.)


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